

## Bulk Loss Measurements of III-V Semiconductor Materials in a Microwave Cavity at Single Photon Powers and Millikelvin Temperatures

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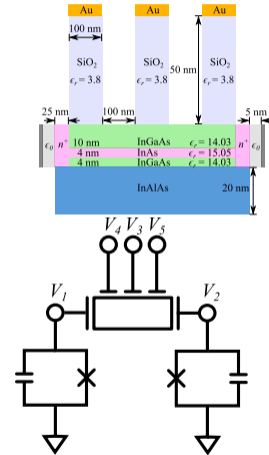
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# Introduction & Motivation

- Motivation: voltage-tunable couplers and gatemons



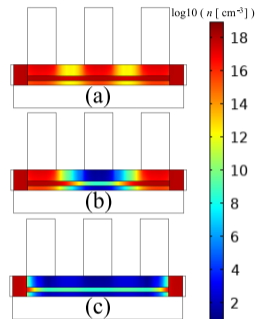
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	$t_j$ [nm]	$p_j$	$\delta_j$
InGaAs	10	2.08E-5	?
InAs	4.0	3.18E-5	?
InGaAs	4.0	2.86E-5	?
InAlAs	20	5.64E-4	?
InP	3.5E+3	2.92E-2	?
Al <sub>2</sub> O <sub>3</sub> <sup>3</sup>	50	9.04E-1	5.00E-3
Total	-	-	5.00E-3

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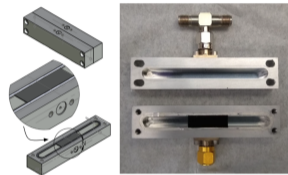
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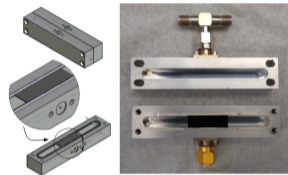
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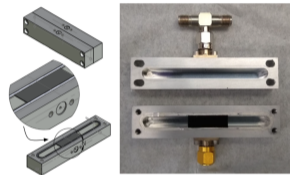
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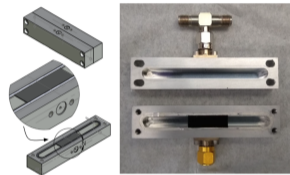
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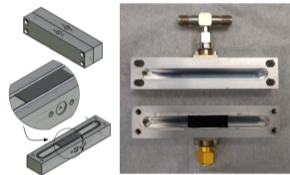
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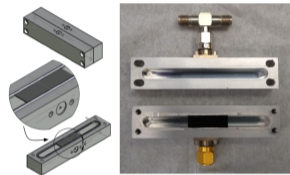
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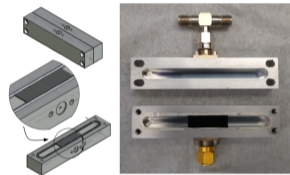
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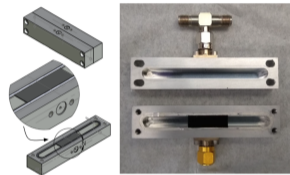
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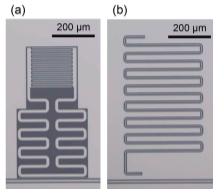
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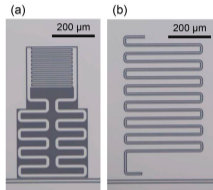
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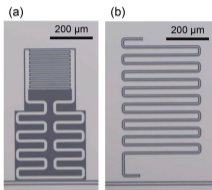
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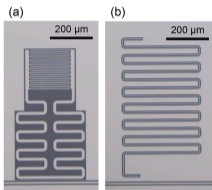
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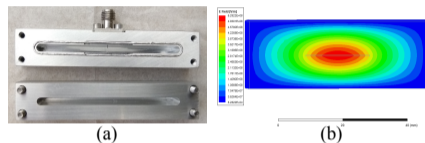
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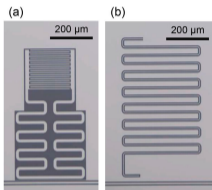


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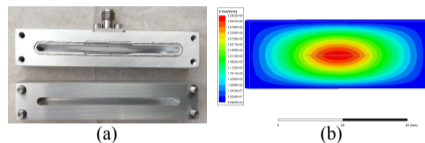
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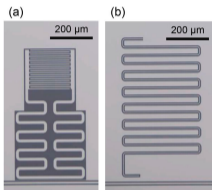
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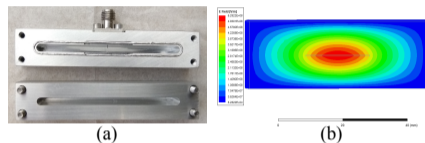
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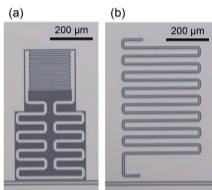
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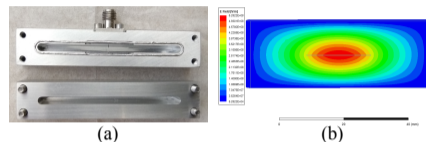
- ▶ Ease of tuning the coupling quality factor,  $Q_c \sim Q_i$
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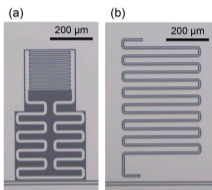


	Cavity	Substrate (InP)
$p_{\text{surf}}$	5.8e-05	2e-05
$p_{\text{bulk}}$	0.97	0.36
$p_{\text{surf,norm}}$	4.3e-05	1.5e-05
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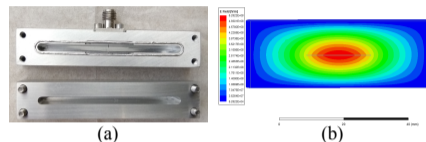
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- ▶ Total loss, TLS loss from <sup>3,7</sup>

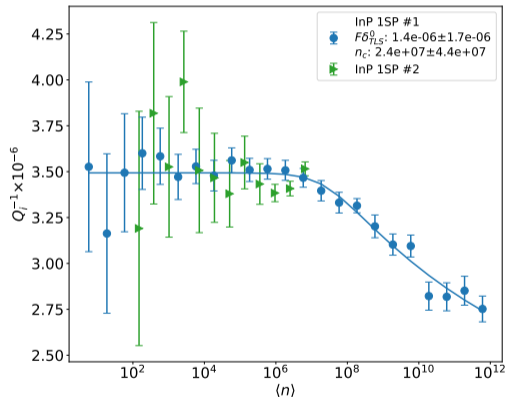
$$Q_i^{-1} = \tan \delta \simeq \delta, \delta \ll 1 \quad (1)$$

$$\delta_{\text{tot}} = \delta_{\text{TLS}} + \delta_{\text{other}} \quad (2)$$

$$\delta_{\text{TLS}} = F \delta_{\text{TLS}}^0 \frac{\tanh\left(\frac{\hbar\omega_0}{2k_B T}\right)}{\left(1 + \frac{\langle n \rangle}{n_c}\right)^\beta} \quad (3)$$

- ▶ Repeated 1SP InP measurements agree for  $\langle n \rangle < n_c$

## Repeated 1SP InP Cavity Measurements



<sup>3</sup>McRae et al., Review of Scientific Instruments **91**, 091101 (2020).

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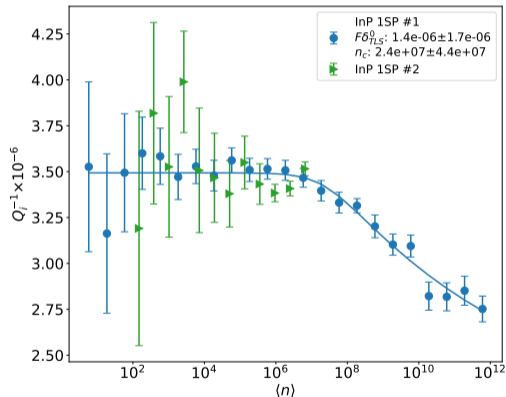
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# Mattis-Bardeen Theory

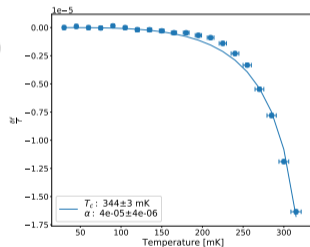
- ▶ Fractional frequency shift from Mattis-Bardeen theory, two fluid model<sup>8,9</sup>

$$\frac{\delta f}{f} = \frac{f - f(T_{min})}{f} = \frac{\alpha}{2} \left( 1 - \frac{1}{\sqrt{1 - (T/T_c)^4}} \right) \quad (4)$$

- ▶ Kinetic inductance fraction is related to the magnetic participation ratio by<sup>10</sup>

$$\alpha = \lambda_L \rho_m = \lambda_L \frac{\int_S |\mathbf{H}|^2 dS}{\int_V |\mathbf{H}|^2 dV} \quad (5)$$

Planar Al CPW Resonator on InP (NYU)



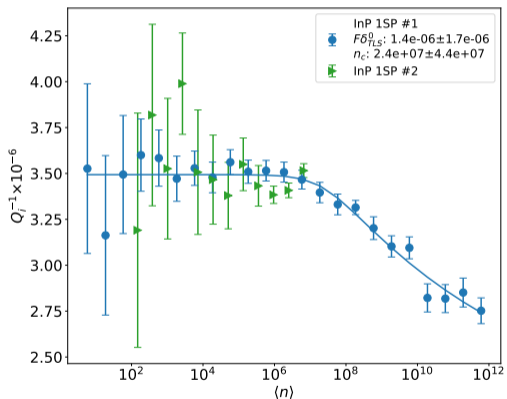
<sup>8</sup>Holland et al., Applied Physics Letters **111**, 202602 (2017).

<sup>9</sup>Turneaure, Halbritter, and Schwettman, Journal of Superconductivity **4**, 341 (1991).

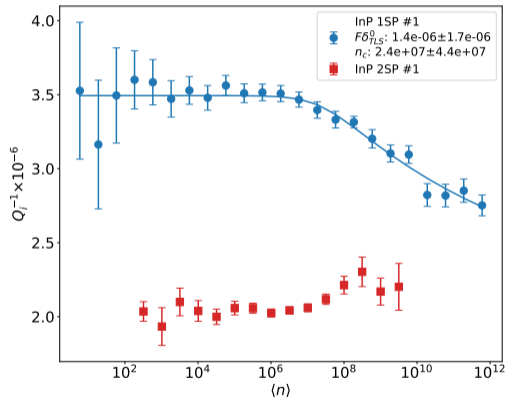
<sup>10</sup>Reagor et al., Applied Physics Letters **102**, 192604 (2013).

# Measure samples with / without etching (1SP, 2SP InP)

## Repeated 1SP InP Cavity Measurements



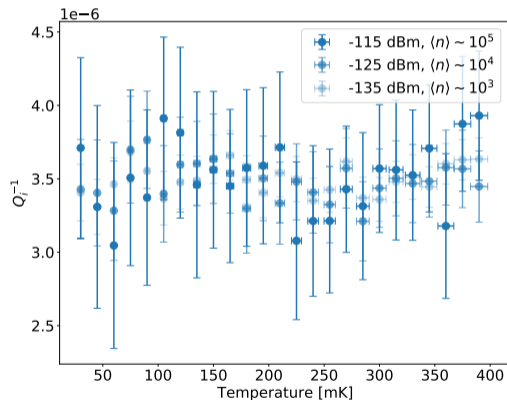
## 1SP InP, 2SP InP Loss Comparison





# Measure samples with / without etching (1SP, 2SP InP)

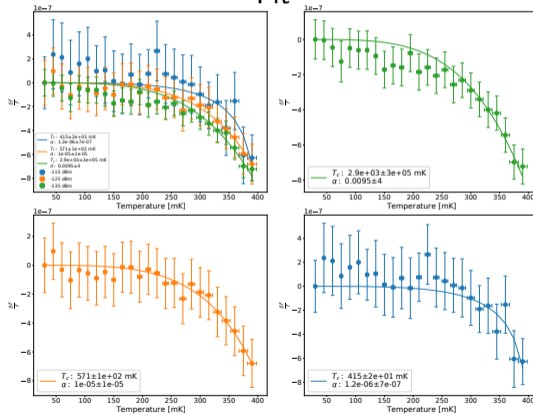
## Temperature Sweep, 1SP InP



# Measure samples with / without etching (1SP, 2SP InP)

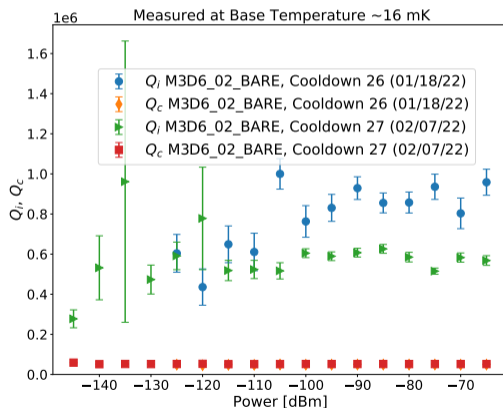
## Frequency Shifts, 1SP InP: Mattis-Bardeen

Fit



# Measure samples with / without etching (1SP, 2SP InP)

Power Sweep, Bare Cavity (9.2 GHz):  
Overcoupled.

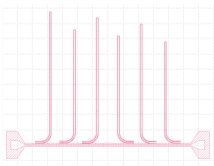


## Compare with CPW AI on InP measurements

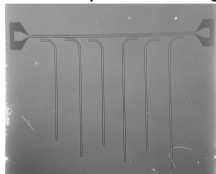
Image of Sample Package



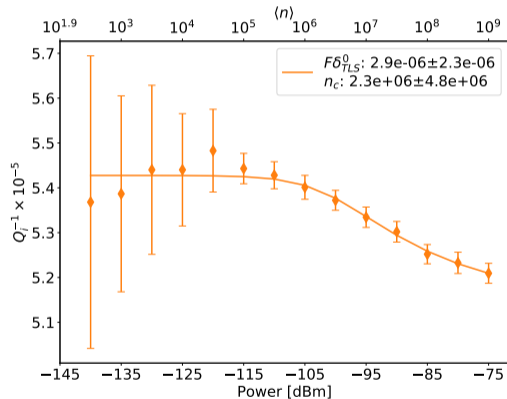
Six Resonator GDS



Optical Image



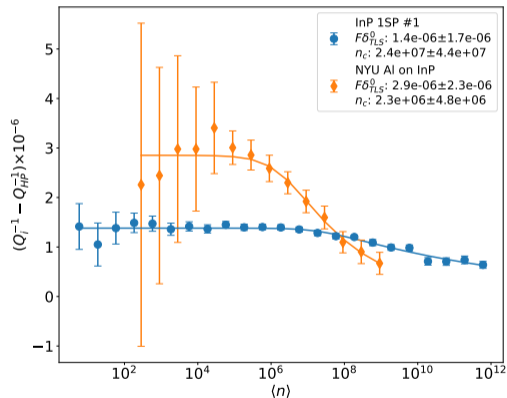
Loss vs. Power – Not TLS Dominated



## Compare with CPW AI on InP measurements

- ▶ Subtract  $Q_{HP}^{-1}$  offsets to compare power dependence
- ▶ Comparable  $F\delta_{TLS}^0$ , in CPW and cavity measurements
- ▶ 10x larger  $n_c$  in cavity relative to CPW  $\Rightarrow$  need more photons *in the cavity* to saturate TLS
- ▶ Different power dependence – surface roughness vs. interface losses

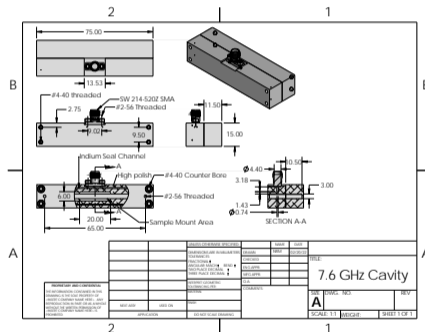
### Comparison of 1SP InP & CPW AI on InP



## Next Steps

- ▶ Improve  $Q_i/Q_c$  match in the bare cavity measurements<sup>11</sup>

## New Cavity Design, Lower Frequency



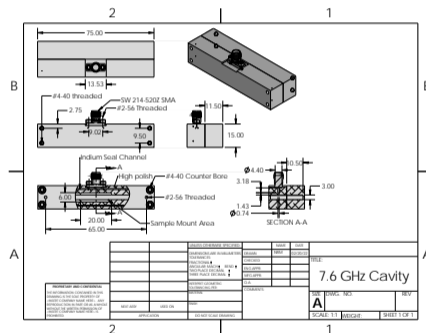
<sup>7</sup>Scigliuzzo et al., *New Journal of Physics* 22, 053027 (2020).

<sup>11</sup>M. Reagor, PhD Thesis, (2015).

## Next Steps

- ▶ Improve  $Q_i/Q_c$  match in the bare cavity measurements<sup>11</sup>
- ▶ Measure the new cavity with a lower resonance frequency – bare, with  $SiO_x$ , with 1SP InP, with 2SP InP, and remaining III-V's in NYU stack

## New Cavity Design, Lower Frequency



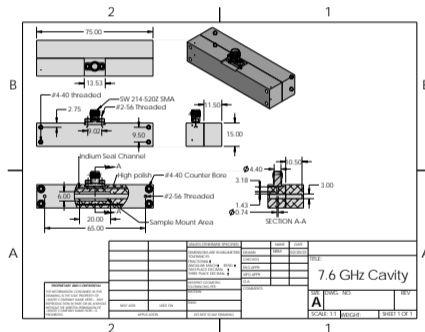
<sup>7</sup>Scigliuzzo et al., *New Journal of Physics* 22, 053027 (2020).

<sup>11</sup>M. Reagor, PhD Thesis, (2015).

## Next Steps

- ▶ Improve  $Q_i/Q_c$  match in the bare cavity measurements<sup>11</sup>
- ▶ Measure the new cavity with a lower resonance frequency – bare, with  $SiO_x$ , with 1SP InP, with 2SP InP, and remaining III-V's in NYU stack
- ▶ Develop a basic theory for piezoelectric loss and compare with dominant  $\delta_{other}$ <sup>7</sup>

## New Cavity Design, Lower Frequency



<sup>7</sup>Scigliuzzo et al., *New Journal of Physics* 22, 053027 (2020).

<sup>11</sup>M. Reagor, PhD Thesis, (2015).



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